



Docket No.: 0020-5179P
(PATENT)

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:
Zhiqiang WEI et al.

Application No.: 10/665,496

Confirmation No.: 6865

Filed: September 22, 2003

Art Unit: 1762

For: A THIN FILM METAL OXIDE AND A
METHOD FOR PREPARING IT

Examiner: M. B. Cleveland

AMENDMENT IN RESPONSE TO FINAL OFFICE ACTION

MS RCE
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

INTRODUCTORY COMMENTS

In response to the Office Action dated January 9, 2006, please amend the above-identified U.S. patent application as follows:

Amendments to the Claims begin on page 2 of this paper.

Remarks/Arguments begin on page 8 of this paper.

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